

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/769,204	CHUNG, CHIA-CHI
	Examiner	Art Unit
	Hsien-ming Lee	2823

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
257	314-316	10/26/05	Lee
257	324, 324		
438	261-263	↓	↓